#### 503818797 05/10/2016

## PATENT ASSIGNMENT COVER SHEET

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EPAS ID: PAT3865446

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

#### **CONVEYING PARTY DATA**

Name	Execution Date
SHUNPEI YAMAZAKI	12/16/2013
HIDEOMI SUZAWA	12/17/2013
HIROSHI FUJIKI	12/18/2013
HIROMICHI GODO	12/19/2013
YASUMASA YAMANE	12/17/2013

#### **RECEIVING PARTY DATA**

Name:	SEMICONDUCTOR ENERGY LABORATORY CO., LTD.
Street Address:	398, HASE
City:	ATSUGI-SHI, KANAGAWA-KEN
State/Country:	JAPAN
Postal Code:	243-0036

### **PROPERTY NUMBERS Total: 1**

Property Type	Number
Application Number:	15066018

### **CORRESPONDENCE DATA**

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ATTORNEY DOCKET NUMBER:	12732-1270002
NAME OF SUBMITTER:	JANELLE A. JACKSON
SIGNATURE:	/Janelle A. Jackson/
DATE SIGNED:	05/10/2016

**Total Attachments: 2** 

**PATENT** REEL: 038529 FRAME: 0414

503818797

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PATENT REEL: 038529 FRAME: 0415

Attorney Docket No. 12732-1270002 Client Ref. US18142-D1 Page 1

# **ASSIGNMENT**

For valuable consideration, We. Shunpei YAMAZAKI of Setagaya, Tokyo, Japan, Hideomi SUZAWA of Atsugi, Kanagawa, Japan, Hiroshi FUJIKI of Atsugi, Kanagawa, Japan, Hiromichi GODO of Isehara, Kanagawa, Japan and Yasumasa YAMANE of Atsugi, Kanagawa, Japan hereby assign to Semiconductor Energy Laboratory Co., Ltd., a Japanese corporation having a place of business at:

398, Hase, Atsugi-shi, Kanagawa-ken, 243-0036 Japan

and its successors and assigns (collectively hereinafter called "the Assignee"), the entire right, title and
interest throughout the world in the inventions and improvements which are subject of an application for
United States Patent signed by us this day, entitled <u>SEMICONDUCTOR DEVICE AND METHOD FOR</u>
MANUFACTURING THE SAME, filed December 27, 2013 . and assigned U.S. Serial
Number $14/141,831$ , and we authorize and request the attorneys appointed in said application
to hereafter complete this assignment by inserting above the filing date and serial number of said application
when known; this assignment including said application, any and all United States and foreign patents.
utility models, and design registrations granted for any of said inventions or improvements, and the right to
claim priority based on the filing date of said application under the International Convention for the
Protection of Industrial Property, the Patent Cooperation Treaty, the European Patent Convention, and all
other treaties of like purposes; and we authorize the Assignee to apply in all countries in our name or in its
own name for patents, utility models, design registrations and like rights of exclusion and for inventors'
certificates for said inventions and improvements: and we agree for ourselves and our respective heirs, legal
representatives and assigns, without further compensation to perform such lawful acts and to sign such
further applications, assignments, Preliminary Statements and other lawful documents as the Assignee may
reasonably request to effectuate fully this assignment.

Signature	Sluga Beengele
Name:	Shunpei YAMAZAKI
Date:	12/16/2013
Signature Name: Date:	Alideomi Sugawas Hideomi SUZAWA 12/17/2013
Signature	Hirski Jujiki
Name:	Hiroshi FUNKI
Date:	12/18/2013

Attorney Docket No. 12732-1270002 Client Ref. US18142-D1

Signatur Onomichi Godo

Name: Hiromichi GODO

Date: 12/19/2013

Signatur Yasumasa Yamane

Name: Yasumasa YAMANE

12/17/2013

Date:

PATENT REEL: 038529 FRAME: 0417

**RECORDED: 05/10/2016**